

Docket No.: 0171-1063P

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Youichi OHSAWA et al.

Application No.: 10/776,159

Filed: February 12, 2004 Art Unit: 1626

For: NOVEL SULFONYLDIAZOMETHANES,

PHOTOACID GENERATORS, RESIST COMPOSITIONS, AND PATTERNING

PROCESS

Examiner: F. Powers

Confirmation No.: 3759

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 21, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.